



12.63479

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application )

Applicant: Hongyong Zhang )

Serial No.: 09/468,489 )

Filing Date: December 20, 1999 )

For: THIN FILM TRANSISTOR HAVING  
LIGHTLY AND HEAVILY DOPED  
SOURCE/DRAIN REGIONS AND ITS  
MANUFACTURE )

Art Unit: 2814 )

Examiner: Quach, T. )

I hereby certify that this paper is being deposited with  
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No. 47,954

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Assistant Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

Please direct all future correspondence concerning the above-identified  
Application to the following address:

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Respectfully submitted,

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